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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheet as necessary)		Complete if Known	
		Application Number	filed herewith
		Filing Date	filed herewith
		First Named Inventor	LI, Chien-Wei
		Group Art Unit	1762
Examiner Name	Marianne Padgett		
Sheet 1 of 2	Attorney Docket Number		H0003762-1170

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
	1	US- 6,585,823	07-01-2003	VAN WIJCK	
	2	US- 2003-0059633 A1	03-27-2003	ACKERMAN et al.	
	3	US- 2003-0026989 A1	02-06-2003	GEORGE et al.	
	4	US- 6,503,330 B1	01-07-2003	SNEH et al.	
	5	US- 6,492,038 B1	12-10-2002	RIGNEY et al.	
	6	US- 6,416,870 B1	07-09-2002	HUNT et al.	
	7	US- 6,203,927 B1	03-20-2001	SUBRAMANIAN et al.	
	8	US- 6,203,613 B1	03-20-2001	GATES et al.	
	9	US- 6,103,386 A1	08-15-2000	RAYBOULD et al.	
	10	US- 5,998,003	12-07-1999	COURTRIGHT et al.	
	11	US- 5,855,753	01-05-1999	TRAU et al.	
MLP	12	US- 5,562,998	10-08-1996	STRANGMAN	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. 1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T 3
		'Country Code ' Number ' Kind Code ' (if known)				
MLP	13	WO 03/058734 A1	07-17-2003	CHAN, Chung M., et al.	in English	

Examiner Signature	 /Marianne L. Padgett/	Date Considered	06/17/2006
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent documents. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard SL16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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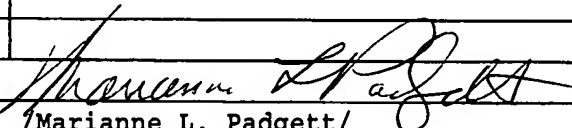
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		Group Art Unit	1762
Examiner Name	Marianne Padgett		
Sheet 2 of 2	Attorney Docket Number H0003762-1170		

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
MLP	14	RITALA, Mikko, et al., <i>Atomic Layer Deposition</i> , Handbook of Thin Film Materials, October 2001, Volume 1, Chapter 2; San Diego, U.S.	
MLP	15	SNEH, Ofer, et al., <i>Thin Film Atomic Layer Deposition Equipment for Semiconductor Processing</i> ; Thin Solid Films 402 (2002); pp. 248-261 (no month)	

Examiner Signature	Marianne L. Padgett/ 	Date Considered	06/17/2006
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